

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Kaoru YAMADA et al. : Mail Stop: PCT

Serial No. NEW : Attorney Docket No. 2006-0044A

Filed January 18, 2006 :

SUBSTRATE PROCESSING APPARATUS,
SUBSTRATE PROCESSING METHOD, AND
SUBSTRATE HOLDING APPARATUS
[Corresponding to PCT/JP2004/011101

Filed July 28, 2004

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced U.S. patent application please amend the application as follows: